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Docket No.: 0756-2149

2811
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5-13-03
Ratola

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

International Patent Application of

Hisashi OHNITANI et al.) Group Art Unit: 2811

Serial No. 09/593,765) Examiner: C. Nguyen

Filed: June 14, 2000)

For: METHOD FOR MANUFACTURING)

A SEMICONDUCTOR DEVICE)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20131, on April 30, 2003

Timothy D. Luni

**THIRD REQUEST FOR ACKNOWLEDGMENT OF
INFORMATION DISCLOSURE STATEMENT**

Honorable Commissioner for Patents

Washington, D.C. 20231

Sir:

Applicants acknowledge with appreciation the Advisory Action mailed July 3, 2002.

The Advisory Action did not, however, include an initialed Form PTO-1449 acknowledging the Information Disclosure Statement filed November 13, 2001. Therefore, it is respectfully requested that the Examiner evidence consideration of the references cited in the IDS of November 13, 2001 by providing a copy of the initialed Form PTO-1449.

If a conference would be beneficial in expediting the prosecution of the instant application, the Examiner is invited to telephone the undersigned to arrange such a conference.

Respectfully submitted,

Eric J. Robinson
Registration No. 38,285

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